



461

2812
13

Attorney Docket No.: SEL 139 DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shunpei Yamazaki et al.)
Serial No.: 09/808,162)
Filed: March 13, 2001)
For: Method For Fabricating A)
Semiconductor Device)
Examiner: V. Simkovic)
Art Unit: 2812)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on

June 30, 2003
(Date of Deposit)

Shannon Wallace
Name of applicant, assignee, or Registered Rep.

Shannon Wallace 6/30/2003
Signature Date

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT B

In response to the Office Action of March 28, 2003, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

RECEIVED
JUL - 9 2003
TECHNOLOGY CENTER 2800

13 (Amended). A method according to claim 1 further comprising the step of:

carrying out a second heat treatment at a temperature of not lower than 900°C.